



PATENT  
20059/PIA30746

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Young Guen Lee

Serial No.: 10/627,057

For: RF SEMICONDUCTOR  
DEVICES AND METHOD FOR  
FABRICATING THE SAME

Filed: July 25, 2003

Group Art Unit: 2822

Examiner: Maria F. Guerrero

) I hereby certify that this paper is  
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) this date:

November 12, 2004

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Attorney for Applicants

RESPONSE TO THE OFFICE ACTION DATED JULY 12, 2004

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated July 12, 2004, please enter the following amendments and consider the following remarks:

**The Amendments to the Specification** begin on page 2 of this paper.

**The Amendments to the Drawings** are discussed on page 3 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 4 of this paper.

**Remarks** begin on page 8 of this paper.